

GAU-2814 \$

AMENDMENT TRANSMITTAL LETTER (Large Entity)	Docket No. 11675.107
Applicant(s): David Y. Kao, et al.	

Serial No. 08722693	Filing Date October 2, 1996	Examiner George Fourson	Group Art Unit 2814
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Invention: OXIDATION OF ION IMPLANTED SEMICONDUCTORS



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TO THE ASSISTANT COMMISSIONER FOR PATENTS

Transmitted herewith is an amendment in the above-identified application.
The fee has been calculated and is transmitted as shown below.

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CLAIMS AS AMENDED						ADDITIONAL FEE
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE		
TOTAL CLAIMS	44 -	42 =	2 x	\$22.00		\$44.00
INDEP. CLAIMS	6 -	6 =	0 x	\$82.00		\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>						\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$44.00

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- ☐ No additional fee is required for amendment.
- ☐ Please charge Deposit Account No. _____ in the amount of _____
A duplicate copy of this sheet is enclosed.
- ☒ A check in the amount of \$44.00 to cover the filing fee is enclosed.
- ☒ The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 23-3178
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- ☒ Any additional filing fees required under 37 C.F.R. 1.16.
- ☒ Any patent application processing fees under 37 CFR 1.17.

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Bradley K. DeSandro
Signature

Dated: June 19, 1998

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I certify that this document and fee is being deposited on June 19, 1998 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.	
<i>Dianne Freedman</i> Signature of Person Mailing Correspondence	
Dianne Freedman Typed or Printed Name of Person Mailing Correspondence	



PATENT APPLICATION

Docket No: 11675-10

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

David Y. Kao, et al.

Serial No.: 08/720,693

Filed: October 2, 1996

For: OXIDATION OF ION IMPLANTED
SEMICONDUCTORS

Examiner: George Fourson

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Group Art Unit

2814

AMENDMENT A UNDER 35 U.S.C. § 1.115Honorable Commissioner of Patents
and Trademarks
Washington, D.C. 20231

Sir:

IN THE SPECIFICATION

Page 14, line 19: change "4" to --7--;

Page 17, line 11 and Page 23, line 2:

change "charge characteristic" to -- conductivity type --;

Page 25, line 15: change "17" to --15--.

IN THE Claims

In the claims, please amend Claims 1-33 as follows:

06/29/1998 SSANDARA 00000008 08720693

01 FC:103

44.00 DP

04/07/2000 AFORD1 00000004 233:76 08720653

01 FC:115

110.00 CH

COMMUNICATIONS SECTION

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